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PATENT
Docket No. P1572

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: JENNIFER WANG
HUI-MIN SHENG
MIKE BARSKY

SERIAL NO. 10/782,723 **EXAMINER:** CHEN, KIN CHAN

FILED: FEBRUARY 18, 2005 **ART UNIT:** 1765

TITLE: DRY ETCHING PROCESS FOR COMPOUND
SEMICONDUCTOR

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RESPONSE AND AMENDMENT

Sir:

Applicants submit this Request for Continued Examination and Amendment in response to the Office Action of June 13, 2006. Please amend the application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.